



**EXPEDITED PROCEDURE – EXAMINING GROUP 1763**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Trung T. Doan	Examiner:	Sylvia MacArthur
Serial No.:	09/652,713	Group Art Unit:	1763
Filed:	August 31, 2000	Docket No.:	303.928US5
Title:	CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING		

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**AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In response to the Final Office Action mailed May 16, 2006, please amend the application as follows:

This response is accompanied by a Petition, as well as the appropriate fee, to obtain a one-month extension of the period for responding to the Office action, thereby moving the deadline for response from August 16, 2006 to September 16, 2006.